



Docket No.: 42390P5771D

#15/I.D.S

2/13/03

Adm H

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of:

CHUNLIN LIANG, ET AL.

Application No.: 09/517,705

Filed: March 2, 2000

For: **COMPLEMENTARY METAL GATE  
ELECTRODE TECHNOLOGY**

Art Group: 2811

Examiner: Steven Ho Yin Lee

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**INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §1.97**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

In accordance with the duty of disclosure, enclosed is a copy of Information Disclosure Statement by Applicant (form PTO/SB/08), which is being submitted . It is respectfully requested that the cited references be considered and that the enclosed copy of PTO/SB/08 be initialed by the Examiner to indicate such consideration and a copy thereof returned to applicant(s). Copies of the references cited on PTO/SB/08 are enclosed herewith.

The submission of this Information Disclosure Statement is not to be construed as a representation that a search has been made in the subject application and is not to be construed as an admission that the information cited in this statement is material to patentability.

Respectfully submitted,

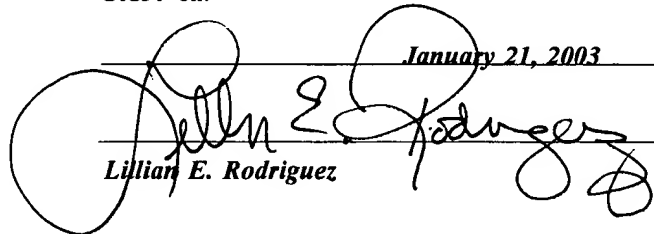
BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN LLP

Date: January 21, 2003

  
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I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class mail with sufficient postage in an envelope addressed to: Box RCE, Assistant Commissioner for Patents, Washington, D.C. 20231 on:

  
Lillian E. Rodriguez  
January 21, 2003  
01-21-03  
Date